



ITW

Docket No.: 9553.004.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hideaki Machida

Application No.: 10/732,812

Filed: December 11, 2003

For: COPPER FOUNDATION MEMBRANE
FORMATION MATERIAL

Confirmation No.: 5892

Group Art Unit: 1621

Examiner: Yevgeny Valenrod

Customer No.: 30827

Mail Stop AF
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

REQUEST FOR RECONSIDERATION

In response to the Office Action dated May 9, 2007, please amend the above-identified application as follows:

A Listing of the Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.